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EHF 2001,0167 P

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By:

Wang Hong Chen

Date:

April 25, 2005IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 09/873,230 Confirmation No. 4487
Applicant : Norbert Benesch et al.
Filed : June 4, 2001
TC/A.U. : 2625
Examiner : John B. Strege
Title : Method and Device for Optically Monitoring
Fabrication Processes of Finely Structured
Surfaces in a Semiconductor Production

Docket No. : EHF 2001,0167 P
Customer No. : 24131

BOX AF

Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT under 37 C.F.R. § 1.116

S i r :

In response to the final Office action dated January 24, 2005,
please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of
claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 15 of this paper.